

In re application of: Jong-won LEE et al.

Serial No.: 09/899,627

Group: Art Unit 2822

Filed: July 5, 2001

Examiner: Guerrero, Maria E.

For: **SOLUTION FOR CHEMICAL MECHANICAL POLISHING AND METHOD OF MANUFACTURING COPPER METAL INTERCONNECTION LAYER USING THE SAME**

**Mail Stop Non Fee Amendment**

Commissioner for Patents  
PO Box 1450  
Alexandria VA 22313-1450

**AMENDMENT TRANSMITTAL FORM**

Sir:

Transmitted herewith is an amendment in the above-identified application.

- ☐ Small entity status of this application under 37 C.F.R. § 1.9 and 1.27 has been established by a verified statement previously submitted.  
☐ A verified statement to establish small entity under 37 C.F.R. § 1.9 and 1.27 is enclosed.  
☒ No additional fee is required.

The fee has been calculated as shown below:

|  | (Col. 1)                                  | (Col. 2)                              | (Col. 3)         | SMALL ENTITY | OTHER THAN<br>SMALL ENTITY |
|--|---|---------------------------------------|------------------|--------------|----------------------------|
|  | CLAIMS<br>REMAINING<br>AFTER<br>AMENDMENT | HIGHEST NO.<br>PREVIOUSLY<br>PAID FOR | PRESENT<br>EXTRA | RATE         | ADDIT.<br>FEE              |
| TOTAL  | 15 *                                      | MINUS 20**                            | = 0              | X 9          | \$ 0                       |
| INDEP.   | 1 *                                       | MINUS 3***                            | = 0              | X 43         | \$ 0                       |
| <input type="checkbox"/> FIRST PRESENTATION OF MULTIPLE DEP. CLAIM |   |                                       |                  | X 145        | \$ 0                       |
|  |   |                                       |                  | TOTAL        | OR TOTAL \$ 0              |
|  |   |                                       |                  | ADDIT. FEE   | \$ 0                       |

\* If the entry in Co. 1 is less than entry in Col. 2, write "0" in Col. 3.

\*\* If the "Highest No. Previously Paid for" IN THIS SPACE is less than 20, enter "20".


\*\*\* If the "Highest No. Previously Paid For" IN THIS SPACE is less than 3, enter "3".

The Highest No. Previously Paid For" (Total or indep.) is the highest number found in the appropriate box in Col. 1 of a prior amendment or the number of claims originally filed.

- ☐ Please charge Deposit Account No. \_\_\_\_ in the amount of \$\_\_\_\_. Two (2) copies of this sheet are enclosed.  
☐ Please charge fee of \$\_\_\_\_ for \_\_\_\_\_ by Credit Card Payment Form PTO-2038 enclosed herewith  
☒ Please charge any deficiency as well as any other fee(s) which may become due under 37 C.F.R. § 1.16 and/or 1.17 at any time during the pendency of this application, or credit any overpayment of such fee(s) to Deposit Account No. **50-0679**. Also, in the event any extensions of time for responding are required for the pending application(s), please treat this paper as a petition to extend the time as required and charge Deposit Account No. **50-0679** therefor. **TWO (2) COPIES OF THIS SHEET ARE ENCLOSED.**

Respectfully submitted,

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Frank Chau  
Reg. No. 34,136  
Attorney for Applicant

**CERTIFICATE OF MAILING UNDER 37 C.F.R. § 1.8(a)**

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail, postpaid in an envelope, addressed to the: Mail Stop Non Fee Amendment, Commissioner for Patents, Alexandria VA 22313-1450 on **May 24, 2004**.

Dated: 5/24/04

  
Frank Chau

AF/2822  
Tfn



Attorney Docket No. 8021-55 (SS-14743-US)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Jong-won Lee et al. Docket: 8021-55 (SS-14743-US)  
Serial No.: 09/899,627 Group Art Unit: 2822  
Filed: July 5, 2001 Examiner: Guerrero, Maria F.  
For: **SOLUTION FOR CHEMICAL MECHANICAL POLISHING AND  
METHOD OF MANUFACTURING COPPER METAL  
INTERCONNECTION LAYER USING THE SAME**

Mail Stop Non Fee Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

AMENDMENT AFTER FINAL REJECTION UNDER 37 C.F.R. § 1.116


In reply to the Office Action dated March 25, 2004, please amend the above-identified application as follows:

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CERTIFICATE OF MAILING UNDER 37 C.F.R. §1.8(a)

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail, postpaid in an envelope, addressed to the: Mail Stop Non Fee Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on May 24, 2004.

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